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Docket: 0756-945

IN THE UNITED STATES PATENT AND TRADEMARK OFF

In re the Application of)

Hisato SHINOHARA et al.)

Serial No. 08/169,127) Group Art Unit:1506

Filed: December 20, 1993

For: METHOD AND SYSTEM OF

LASER PROCESSING) Date: June 20, 1994

INFORMATION DISCLOSURE STATEMENT

JUN 29

Honorable Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

The references listed on the attached Form PTO-1449 were cited in Serial No. 07/891,907 filed June 1, 1992, and its predecessor application including Serial No. 07/288,106, which is the parent of the subject application.

Respectfully submitted,

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